Refine Search

Search Results -

Terms	Documents
semiconductor and (nanoscale same roughness)	0

Database:

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L7

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Search History

DATE: Wednesday, February 16, 2005   Printable Copy   Create Case

Set Name	Query	Hit Count	Set Name
side by side			result set
	DB=JPAB; PLUR=YES; OP=ADJ		
L7	semiconductor and (nanoscale same roughness)	0	L7
	DB=EPAB; PLUR=YES; OP=ADJ		
L6	semiconductor and (nanoscale same roughness)	0	L6
	DB=USPT; PLUR=YES; OP=ADJ		
L5	semiconductor and (nanoscale same roughness)	24	L5
	DB=PGPB; PLUR=YES; OP=ADJ		
L4	semiconductor and (nanoscale same roughness)	29	L4
	DB=TDBD; PLUR=YES; OP=ADJ		
L3	semiconductor and (nanoscale same roughness)	1	L3
	DB=DWPI; PLUR=YES; OP=ADJ		
L2	semiconductor and (nanoscale same roughness)	1	L2
L1	6417060.pn.	1	L1

END OF SEARCH HISTORY